

Dimitrios Goustouridis

List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/3546376/publications.pdf>

Version: 2024-02-01

86
papers

1,383
citations

304368

22
h-index

414034

32
g-index

86
all docs

86
docs citations

86
times ranked

1425
citing authors

#	ARTICLE	IF	CITATIONS
1	Swelling of poly(3-alkylthiophene) films exposed to solvent vapors and humidity: Evaluation of solubility parameters. <i>Synthetic Metals</i> , 2007, 157, 726-732.	2.1	91
2	Single chip interdigitated electrode capacitive chemical sensor arrays. <i>Sensors and Actuators B: Chemical</i> , 2007, 127, 186-192.	4.0	89
3	Liquid phase direct laser printing of polymers for chemical sensing applications. <i>Applied Physics Letters</i> , 2008, 93, .	1.5	67
4	Fabrication of single crystal Si cantilevers using a dry release process and application in a capacitive-type humidity sensor. <i>Microelectronic Engineering</i> , 2002, 61-62, 955-961.	1.1	45
5	Humidity and solvent effects in spin-coated polythiophene-polystyrene blends. <i>Journal of Applied Polymer Science</i> , 2007, 105, 67-79.	1.3	43
6	Assessment of goat milk adulteration with a label-free monolithically integrated optoelectronic biosensor. <i>Analytical and Bioanalytical Chemistry</i> , 2015, 407, 3995-4004.	1.9	42
7	Vapor sorption in thin supported polymer films studied by white light interferometry. <i>Polymer</i> , 2006, 47, 6117-6122.	1.8	41
8	Simultaneous determination of CRP and D-dimer in human blood plasma samples with White Light Reflectance Spectroscopy. <i>Biosensors and Bioelectronics</i> , 2016, 84, 89-96.	5.3	37
9	Ultrafast Multiplexed-Allergen Detection through Advanced Fluidic Design and Monolithic Interferometric Silicon Chips. <i>Analytical Chemistry</i> , 2018, 90, 9559-9567.	3.2	35
10	A Silicon Thermal Accelerometer Without Solid Proof Mass Using Porous Silicon Thermal Isolation. <i>IEEE Sensors Journal</i> , 2007, 7, 983-989.	2.4	31
11	Simultaneous determination of paraquat and atrazine in water samples with a white light reflectance spectroscopy biosensor. <i>Journal of Hazardous Materials</i> , 2018, 359, 67-75.	6.5	31
12	Ordering domains of spin cast blends of conjugated and dielectric polymers on surfaces patterned by soft- and photo-lithography. <i>Soft Matter</i> , 2009, 5, 234-241.	1.2	30
13	Fast simultaneous detection of three pesticides by a White Light Reflectance Spectroscopy sensing platform. <i>Sensors and Actuators B: Chemical</i> , 2017, 238, 1214-1223.	4.0	30
14	A wireless sensing system for monitoring the workplace environment of an industrial installation. <i>Sensors and Actuators B: Chemical</i> , 2016, 224, 266-274.	4.0	27
15	Characterization of polymer layers for silicon micromachined bilayer chemical sensors using white light interferometry. <i>Sensors and Actuators B: Chemical</i> , 2005, 111-112, 549-554.	4.0	26
16	Metal nano-floating gate memory devices fabricated at low temperature. <i>Microelectronic Engineering</i> , 2006, 83, 1563-1566.	1.1	26
17	A chemical sensor microarray realized by laser printing of polymers. <i>Sensors and Actuators B: Chemical</i> , 2010, 150, 148-153.	4.0	26
18	Capacitive-type chemical sensors using thin silicon/polymer bimorph membranes. <i>Sensors and Actuators B: Chemical</i> , 2004, 103, 392-396.	4.0	25

#	ARTICLE	IF	CITATIONS
19	Surface nano/micro functionalization of PMMA thin films by 157nm irradiation for sensing applications. <i>Applied Surface Science</i> , 2008, 254, 1710-1719.	3.1	25
20	Fast label-free detection of C-reactive protein using broad-band Mach-Zehnder interferometers integrated on silicon chips. <i>Talanta</i> , 2017, 165, 458-465.	2.9	24
21	Fast, sensitive and selective determination of herbicide glyphosate in water samples with a White Light Reflectance Spectroscopy immunosensor. <i>Talanta</i> , 2020, 214, 120854.	2.9	24
22	A Reconfigurable Multichannel Capacitive Sensor Array Interface. <i>IEEE Transactions on Instrumentation and Measurement</i> , 2011, 60, 3214-3221.	2.4	23
23	A flexible capacitive device for pressure and tactile sensing. <i>Procedia Chemistry</i> , 2009, 1, 867-870.	0.7	22
24	A label-free flow-through immunosensor for determination of total- and free-PSA in human serum samples based on white-light reflectance spectroscopy. <i>Sensors and Actuators B: Chemical</i> , 2015, 209, 1041-1048.	4.0	21
25	Rapid and sensitive label-free determination of aflatoxin M1 levels in milk through a White Light Reflectance Spectroscopy immunosensor. <i>Sensors and Actuators B: Chemical</i> , 2019, 282, 104-111.	4.0	21
26	Multiplexed mycotoxins determination employing white light reflectance spectroscopy and silicon chips with silicon oxide areas of different thickness. <i>Biosensors and Bioelectronics</i> , 2020, 153, 112035.	5.3	21
27	Ultraminiature silicon capacitive pressure-sensing elements obtained by silicon fusion bonding. <i>Sensors and Actuators A: Physical</i> , 1998, 68, 269-274.	2.0	20
28	Polymer/BaTiO ₃ nanocomposites based chemocapacitive sensors. <i>Microelectronic Engineering</i> , 2009, 86, 1286-1288.	1.1	19
29	Detection of DNA mutations using a capacitive micro-membrane array. <i>Biosensors and Bioelectronics</i> , 2010, 26, 1588-1592.	5.3	19
30	A solid-state pressure-sensing microsystem for biomedical applications. <i>Sensors and Actuators A: Physical</i> , 1997, 62, 551-555.	2.0	17
31	Development and Bioanalytical Applications of a White Light Reflectance Spectroscopy Label-Free Sensing Platform. <i>Biosensors</i> , 2017, 7, 46.	2.3	17
32	Rapid C-reactive protein determination in whole blood with a White Light Reflectance Spectroscopy label-free immunosensor for Point-of-Care applications. <i>Sensors and Actuators B: Chemical</i> , 2018, 260, 282-288.	4.0	17
33	Low temperature wafer bonding for thin silicon film transfer. <i>Sensors and Actuators A: Physical</i> , 2004, 110, 401-406.	2.0	16
34	A thermal convective accelerometer system based on a silicon sensor—Study and packaging. <i>Sensors and Actuators A: Physical</i> , 2006, 132, 147-153.	2.0	16
35	Detection of the biotin—streptavidin interaction by exploiting surface stress changes on ultrathin Si membranes. <i>Microelectronic Engineering</i> , 2009, 86, 1495-1498.	1.1	16
36	Performance simulation, realization and evaluation of capacitive sensor arrays for the real time detection of volatile organic compounds. <i>Microelectronic Engineering</i> , 2011, 88, 2359-2363.	1.1	15

#	ARTICLE	IF	CITATIONS
37	Chemocapacitor performance modeling by means of polymer swelling optical measurements. <i>Sensors and Actuators B: Chemical</i> , 2012, 171-172, 409-415.	4.0	15
38	Layer-by-layer UV micromachining methodology of epoxy resist embedded microchannels. <i>Microelectronic Engineering</i> , 2006, 83, 1298-1301.	1.1	14
39	A lithographic polymer process sequence for chemical sensing arrays. <i>Microelectronic Engineering</i> , 2006, 83, 1192-1196.	1.1	14
40	Multiwavelength interferometry and competing optical methods for the thermal probing of thin polymeric films. <i>Journal of Applied Polymer Science</i> , 2006, 102, 4764-4774.	1.3	14
41	A miniaturized chemocapacitor system for the detection of volatile organic compounds. <i>Sensors and Actuators B: Chemical</i> , 2013, 177, 776-784.	4.0	14
42	All-Silicon Spectrally Resolved Interferometric Circuit for Multiplexed Diagnostics: A Monolithic Lab-on-a-Chip Integrating All Active and Passive Components. <i>ACS Photonics</i> , 2019, 6, 1694-1705.	3.2	14
43	A miniature self-aligned pressure sensing element. <i>Journal of Micromechanics and Microengineering</i> , 1996, 6, 33-35.	1.5	12
44	Molecular weight and processing effects on the dissolution properties of thin poly(methyl) Tj ETQq0 0 0 rgBT /Overlock 10 Tf,50 462 Td	1.1	12
45	Polymeric film characterization for use in bimorph chemical sensors. <i>Microelectronic Engineering</i> , 2005, 78-79, 118-124.	1.1	11
46	Sequential polymer lithography for chemical sensor arrays. <i>European Polymer Journal</i> , 2007, 43, 4602-4612.	2.6	11
47	Design and fabrication of a Si micromechanical capacitive array for DNA sensing. <i>Microelectronic Engineering</i> , 2008, 85, 1359-1361.	1.1	11
48	White light reflectance spectroscopy biosensing system for fast quantitative prostate specific antigen determination in forensic samples. <i>Talanta</i> , 2017, 175, 443-450.	2.9	10
49	Parameters influencing the flatness and stability of capacitive pressure sensors fabricated with wafer bonding. <i>Sensors and Actuators A: Physical</i> , 1999, 76, 403-408.	2.0	9
50	Fabrication of conductometric chemical sensors by photolithography of conductive polymer composites. <i>Microelectronic Engineering</i> , 2007, 84, 1211-1214.	1.1	9
51	Vapor-induced swelling of supported methacrylic and siloxane polymer films: Determination of interaction parameters. <i>Journal of Applied Polymer Science</i> , 2010, 116, 184-190.	1.3	8
52	Demonstration of a new technology which allows direct sensor integration on flexible substrates. <i>EPJ Applied Physics</i> , 2009, 46, 12507.	0.3	8
53	Characterization of polymer films for use in bimorph chemical sensors. <i>Journal of Physics: Conference Series</i> , 2005, 10, 297-300.	0.3	7
54	Capacitive pressure sensors and switches fabricated using strain compensated SiGeB. <i>Microelectronic Engineering</i> , 2006, 83, 1209-1211.	1.1	7

#	ARTICLE	IF	CITATIONS
55	Aqueous base developable: easy stripping, high aspect ratio negative photoresist for optical and proton beam lithography. <i>Microsystem Technologies</i> , 2008, 14, 1423-1428.	1.2	7
56	Realization and Simulation of High-Aspect-Ratio Micro/Nanostructures by Proton Beam Writing. <i>Japanese Journal of Applied Physics</i> , 2008, 47, 8600-8605.	0.8	7
57	Chemocapacitive sensor arrays on Si substrate: Towards the hybrid integration with read-out electronics. <i>Microelectronic Engineering</i> , 2014, 119, 11-15.	1.1	7
58	A novel system for displacement sensing, integrated on a plastic substrate. <i>Microelectronics Journal</i> , 2009, 40, 1387-1392.	1.1	6
59	A regenerable flow-through affinity sensor for label-free detection of proteins and DNA. <i>Journal of Chromatography B: Analytical Technologies in the Biomedical and Life Sciences</i> , 2010, 878, 237-242.	1.2	6
60	Evaluation of capacitive surface stress biosensors. <i>Microelectronic Engineering</i> , 2012, 90, 37-39.	1.1	6
61	Wireless Sensor Network Based on a Chemocapacitive Sensor Array for the Real-time Monitoring of Industrial Pollutants. <i>Procedia Engineering</i> , 2014, 87, 564-567.	1.2	5
62	Glass Transition Temperature Monitoring in Bilayer and Patterned Photoresist Films. <i>Japanese Journal of Applied Physics</i> , 2004, 43, 5247-5248.	0.8	4
63	Effects of hot carrier and irradiation stresses on advanced excimer laser annealed polycrystalline silicon thin film transistors. <i>Microelectronics Reliability</i> , 2004, 44, 1631-1636.	0.9	4
64	Composite Chemical Sensors Based on Carbon-Filled Patterned Negative Resists. <i>Japanese Journal of Applied Physics</i> , 2007, 46, 6423-6428.	0.8	4
65	Electromagnetic Shielding and Reflection Loss of Conductive Yarn Incorporated Woven Fabrics at the S and X Radar Bands. <i>Journal of Electronic Materials</i> , 2020, 49, 1579-1587.	1.0	4
66	A Chemocapacitive Sensor Array System for Gas Sensing Applications. <i>Sensor Letters</i> , 2011, 9, 577-583.	0.4	4
67	Impact of structural parameters on the performance of silicon micromachined capacitive pressure sensors. <i>Sensors and Actuators A: Physical</i> , 2007, 137, 20-24.	2.0	3
68	Capacitive sensor arrays with controllable deposition of the sensing polymer area for VOCs applications: Design and measurement considerations. <i>Procedia Chemistry</i> , 2009, 1, 176-179.	0.7	3
69	Compensation of Temperature Variations in Chemcapacitive Gas Sensing Systems. <i>Sensor Letters</i> , 2012, 10, 736-741.	0.4	3
70	Protein patterning by micromachined silicon embossing on polymer surfaces. <i>Applied Physics Letters</i> , 2004, 85, 6418-6420.	1.5	2
71	Electrical and optical evaluation of polymer composites for chemical sensing applications. <i>Microelectronic Engineering</i> , 2009, 86, 1289-1292.	1.1	2
72	Chemocapacitance response simulation through polymer swelling and capacitor modeling. <i>Procedia Engineering</i> , 2011, 25, 423-426.	1.2	2

#	ARTICLE	IF	CITATIONS
73	Hybrid integration of microfabricated chemically capacitor arrays with miniaturized read-out electronics towards low-power gas sensing module. <i>Procedia Engineering</i> , 2011, 25, 1117-1120.	1.2	2
74	A Si/SiGe MOSFET utilizing low-temperature wafer bonding. <i>Microelectronic Engineering</i> , 2005, 78-79, 244-247.	1.1	1
75	Wireless Measurement System for Capacitive pressure Sensors Using Strain Compensated SiGeB. , 2007, , .		1
76	Must fermentation progress monitoring by polymer coated capacitive vapour sensor arrays. , 2009, , .		1
77	Ultra-miniaturized monolithically integrated polymer coated Si optoelectronic cantilevers for gas sensing applications. , 2009, , .		1
78	Real-time multi-analyte label-free detection of proteins by white light reflectance spectroscopy. , 2014, , .		1
79	Lithographically tuned one dimensional polymeric photonic crystal arrays. <i>Optics and Laser Technology</i> , 2015, 68, 105-112.	2.2	1
80	Nonlocal Effective Medium (NLEM) for Quantitative Modelling of Nanoroughness in Spectroscopic Reflectance. <i>Photonics</i> , 2022, 9, 499.	0.9	1
81	Miniaturization of Si diaphragms obtained by wafer bonding. <i>Microelectronic Engineering</i> , 1998, 41-42, 437-440.	1.1	0
82	Combination of integrated thermal flow and capacitive pressure sensors for high sensitivity flow measurements in both laminar and turbulent regions. <i>Journal of Physics: Conference Series</i> , 2005, 10, 277-280.	0.3	0
83	Modification of Sensing Properties of Thin Polymer Films by VUV Irradiation. , 2007, , .		0
84	Integrated tool for the spreading, thermal treatment and in situ process monitoring of thick photoresist films. <i>Microelectronic Engineering</i> , 2010, 87, 1115-1119.	1.1	0
85	Polymer Coated Microfabricated Interdigitated Electrodes Arrays for Gas Sensing Applications. <i>Key Engineering Materials</i> , 2011, 495, 87-90.	0.4	0
86	Conceptual Design of a Wireless Strain Monitoring System for Space Applications. <i>Lecture Notes of the Institute for Computer Sciences, Social-Informatics and Telecommunications Engineering</i> , 2009, , 405-410.	0.2	0